

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

|                    |   |
|--------------------|---|
| Title of Invention | METHOD OF FORMING STRAINED SILICON ON INSULATOR |
|--------------------|---|

Application Number :

Confirmation Number:

First Named Applicant: Kern Rim

Attorney Docket Number: YOR920000707US2

Art Unit:

Examiner:

Search string: ( 5659187 or 5906951 or 6059895 or 6023082 or 6080235 or 5963817 or 6310367 or 6339232 or 5006913 or 5240876 or 6603156 ).pn

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date       | Patentee        | Kind | Class | Subclass |
|------|----------|------------|------------|-----------------|------|-------|----------|
|      | 1        | 5659187    | 1997-08-19 | Legoues, et al  |      | 257   | 190      |
|      | 2        | 5906951    | 1999-05-22 | Chu, et al      |      | 438   | 751      |
|      | 3        | 6059895    | 2000-05-09 | Chu, et al      |      | 148   | 33.1     |
|      | 4        | 6023082    | 2000-02-08 | McKee, et al    |      | 257   | 295      |
|      | 5        | 6080235    | 2000-06-27 | McKee, et al    |      | 117   | 2        |
|      | 6        | 5963817    | 1999-10-05 | Chu, et at      |      | 438   | 410      |
|      | 7        | 6310367    | 2001-10-30 | Yagishita et al |      | 257   | 190      |
|      | 8        | 6339232    | 2002-01-15 | Takagi          |      | 257   | 192      |
|      | 9        | 5006913    | 1991-04-09 | Sugahara, et al |      | 357   | 41       |
|      | 10       | 5240876    | 1983-08-31 | Gaul, et al     |      | 437   | 131      |
|      | 11       | 6603156    | 2003-08-05 | Rim             |      | 257   | 190      |

## Signature

|               |      |
|---------------|------|
| Examiner Name | Date |
|               |      |